

# **Notice of References Cited**

Application/Control No.

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Applicant(s)/Patent Under

Reexamination

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Examiner

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Art Unit

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## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6558808	05-2003	Dries et al	428/516
	B	US-5716698	02-1998	Schreck et al	428/323
	C	US-5571613	11-1996	Schuhmann et al	428/323
	D	US-4921749	05-1990	Bossaert et al	428/216
	E	US-6033514	03-2000	Davis et al	156/244.11
	F	US-5529843	06-1996	Dries et al	428/336
	G	US-6094889	08-2000	Van Loon et al	53/450
	H	US-6524720	02-2003	Shah	428/516
	I	US-6528134	03-2003	Buelow et al	428/35.7
	J	US-6579621	06-2003	Shah	428/516
	K	US-6641913	11-2003	Hanyu et al	428/349
	L	US-5932157	08-1999	Dries et al	264/176.1
	M	US-5800913	09-1998	Mauer et al	428/323

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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